



*# GP 1733*  
PATENT  
Docket No: 56117US002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

ALBERT I. EVERAERTS, AUDREY A.  
SHERMAN, JINGJING MA and LANG N.  
NGUYEN

Group Art Unit:

1733

#13/Valde  
4/2/03

Serial No.: 09/697,005  
Filed: October 25, 2000

Examiner: J. Gallagher

For: LATENT, OVER-TACKIFIED, ADHESIVES AND METHODS OF USE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on:

March 18, 2003

Date

*Judy L. Hansen*  
Signature Judy L. Hansen

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In reply to the Office Action mailed November 19, 2002, Applicants submit the following remarks. Reconsideration and withdrawal of the rejections for the reasons discussed below are respectfully requested.

REMARKS

Claims 1-18 are pending in the application.

Claim Rejections Under 35 U.S.C. § 102(b)

Claims 1-18 are rejected under 35 U.S.C. § 102(b) as anticipated by Japanese Patent No. 63-154781 to Hoescht. Based on the English Translation Abstract, the Examiner states that Hoescht discloses the following elements: 1) a base substrate;

*RECEIVED  
MAR 31 2003  
GROUP 1103*